

Notice of References Cited	Application/Control No. 10/801,475	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

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	B	US-6,225,697	05-2001	Iguchi, Manabu	257/758
	C	US-2004/0195670	10-2004	Landis, Howard S.	257/700
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NON-PATENT DOCUMENTS

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	U	Peter Van Zant, Microchip Fabrication, 2000, McGraw-Hill, Pages 398-401.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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